

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination SHIMADA ET AL.	
		Examiner JESSICA L. ELEY	Art Unit 2884	Page 1 of 1

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*	B	US-6,388,256	05-2002	Watton et al.	250/338.4
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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